ACM Research to Present at 30th Annual Roth Conference

March 1, 2018

FREMONT, Calif., March 01, 2018 (GLOBE NEWSWIRE) -- ACM Research, Inc. (NASDAQ:ACMR), a provider of single-wafer wet cleaning equipment used by manufacturers of advanced semiconductors, today announced that the Company will present at the 30th Annual ROTH Conference at the Ritz Carlton in Dana Point, California on Monday, March 12, 2018, at 2:30 PM PDT. Chief Executive Officer David Wang is scheduled to present.

The presentation will be webcast live on the Investor Relations section of the Company's website at http://www.acmrcsh.com/. A recording of the webcast will be available on the website for 90 days following the conference. The Company will host investor meetings throughout the day. Attendance at the conference is by invitation only for clients of ROTH Capital Markets. Interested investors should contact your ROTH Capital Markets sales representative to secure a meeting time.

About ACM Research, Inc.

ACM develops, manufactures and sells single-wafer wet cleaning equipment, which semiconductor manufacturers can use in numerous manufacturing steps to remove particles, contaminants and other random defects, and thereby improve product yield, in fabricating advanced integrated circuits.

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